

Notice of References Cited

Application/Control No.

10/580,231

Applicant(s)/Patent Under
Reexamination
EDWIN ET AL.

Examiner

DANIEL C. MCCracken

Art Unit

1793

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0151654	08-2004	Wei et al.	423/447.3
*	B	US-6,905,544	06-2005	Setoguchi et al.	117/105
*	C	US-5,102,647	04-1992	Yamada et al.	423/447.3
*	D	US-4,268,359	05-1981	Rammier et al.	201/31
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Venegoni, et al., Parametric study for the growth of carbon nanotubes by catalytic chemical vapor deposition in a fluidized bed reactor, Carbon 2002; 40: 1799-1807.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.